


If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No.: 20-0782/AMAT/5699.P3/BKH.

Respectfully submitted,



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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. AMAT/5699.P3/CMP/ CMP/RKK	Serial No. 10/608,404
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Liu, et al.	Confirmation No.: Unknown
(Use several sheets if necessary)		Filing Date June 26, 2003	Group Unknown
Examiner Unknown			

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*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate
	A1	6,440,295	08/27/2002	Wang	205	640	02/04/2000
	A2	6,395,152	05/28/2002	Wang	204	224M	07/02/1999
	A3	6,391,166	05/21/2002	Wang	204	224R	01/15/1999
	A4	6,348,076	02/19/2002	Canaperi, et al.	51	309	12/28/1999
	A5	6,276,996	08/21/2001	Chopra	451	41	11/10/1998
	A6	6,258,721	07/10/2001	Li, et al.	438	693	12/27/1999
	A7	6,234,870	05/22/2001	Uzoh, et al.	451	8	08/24/1999
	A8	6,218,305	04/17/2001	Hosali, et al.	438	691	05/25/2000
	A9	6,217,416	04/17/2001	Kaufman, et al.	451	41	06/26/1998
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	A12	6,190,237	02/20/2001	Huyng, et al.	451	41	11/06/1997
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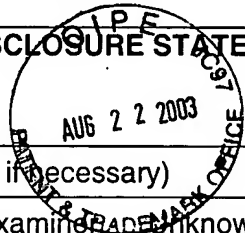
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*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
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	B2	1 103 346 A2	05/30/2001	EP	B24B	37/04	<input checked="" type="checkbox"/>	<input type="checkbox"/>
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	C1	Nogami, "An Innovation to Integrate Porous Low-K Materials and Copper", <u>InterConnect Japan 2001</u> ; Honeywell Seminar (December 6, 2001) PP. 1 – 12
	C2	D. Landolt, "Fundamental Aspects of Electropolishing", 03/18/1996, pages: 1-11
Examiner		Date Considered

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(Use several sheets if necessary)		Filing Date June 26, 2003	Group Unknown
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	A19	6,117,775	09/12/2000	Kondo, et al.	438	690	10/30/1998
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	A26	5,954,997	09/21/1999	Kaufman, et al.	252	79.1	12/09/1996
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*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
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	B4	0 811 665 A3	12/10/1997	EP	C09G	01/02	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B5	P2001-77117A	03/23/2001	JP (English Abstract)	H01L	21/3205	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B6	1 618 538 A1	01/07/1991	SU	B23	H5/6	<input type="checkbox"/>	<input checked="" type="checkbox"/>

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	C3	Robert J. Contolini, "Electrochemical Planarization of ULSI Copper" June 1997, Solid State Technology, pages 155-156, 158 and 160.
Examiner		Date Considered

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Applicant	Confirmation No.:
(Use several sheets if necessary)	Liu, et al.	Unknown
Examiner Unknown	Filing Date	Group
	June 26, 2003	Unknown

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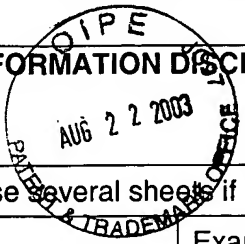
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	A30	5,575,706	11/19/1996	Tsai, et al	451	41	01/11/1996
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	A32	5,534,106	07/09/1996	Cote, et al	156	636.1	07/26/1995
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							YES	NO
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	B8	02/88229	11/07/2002	WO	C08J	5/00	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B9	02/23616	03/21/2002	WO	H01L	21/44	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B10	07/7241 A2	10/18/2001	WO	C09G	01/00	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B11	00/26443	05/11/2000	WO	C25D	N/A	<input checked="" type="checkbox"/>	<input type="checkbox"/>

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(Use several sheets if necessary)		Filing Date June 26, 2003	Group Unknown
Examiner Unknown			

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	A43	2003/0116445	06/26/2003	Sun, et al.	205	674	05/07/2002
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	A45	2002/0070126	06/13/2002	Sato, et al.	205	640	09/19/2001
	A46	2002/0008036	01/24/2002	Wang	205	118	04/18/2001
	A47	2002/0040100	04/04/2002	Kume, et al.	525	89	07/11/2001
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	B12	00/55876 A1	09/21/2000	WO	H01G	09/035	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B13	00/03426	01/20/2000	WO	H01L	21/321	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B14	99/65072	12/16/1999	WO	H01L	21/321	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B15	99/53532	10/21/1999	WO	H01L	21/00	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B16	98/04646	02/05/1998	WO	H01L	21/00	<input checked="" type="checkbox"/>	<input type="checkbox"/>
	B17	98/49723	11/05/1998	WO	H01L	21/321	<input checked="" type="checkbox"/>	<input type="checkbox"/>

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	C4	Partial International Search Report for US 02/40754 dated April 28, 2003 (AMAT/5998.PCT)
	C5	International Search Report for US 02/04806 dated April 1, 2003 (AMAT/5699.PC)
	C6	PCT International Search Report for US 03/06058 dated June 25, 2003. (AMAT/5699.PC.02)

Examiner

Date Considered

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